IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Hiroshi KUROSAWA	: Previous Examiner: D. Ben Esplin) : Previous Group Art Unit: 2851) :
Filed: October 2, 2003) :
For: EXPOSURE APPARATUS, MAINTENANCE : METHOD THEREFOR, SEMICONDUCTOR DEVICE MANUFACTURING METHOD, AND SEMICONDUCTOR MANUFACTURING FACTORY	
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Mail Stop Patent Application

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

<u>INFORMATION DISCLOSURE STATEMENT</u>

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the listed documents are also enclosed.

These documents were cited during prosecution of copending parent application no. 09/858,964, filed May 17, 2001.

Applicant requests that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits. Therefore, no fee under 37 C.F.R. 1.97(c)(2) is believed due.

Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

Applicant's undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our

address given below.

Respectfully submitted,

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SEW/eab

FORM PTO 1449 (modified) ATTY DOCKET NO. 00862.02227.1 APPLICATION NO. Divisional of Appln. No. 09/858,964, filed U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE May 17, 2001 LIST OF REFERENCES CITED BY APPLICANT(S) APPLICANT Hiroshi KUROSAWA (Use several sheets if necessary) October 2, 2003 FILING DATE October 2, 2003 **GROUP 2851** U.S. PATENT DOCUMENTS *EXAMINER INITIAL DOCUMENT NUMBER FILING DATE IF APPROPRIATE DATE NAME **CLASS SUBCLASS** US-4,849,901 07/18/1989 Shimizu 364 468 US-5,112,133 05/12/1992 Kurosawa et al. 356 401 US-5,182,615 01/26/1993 Kurosawa et al. 356 400 US-5,883,701 03/16/1999 Hasegawa et al. 355 53 US-6,028,659 02/22/2000 Kaneko 355 53 US-6,198,982 03/06/2001 Park et al. 700 121 US-6,215,896 04/10/2001 Greig et al. 382 149 US-6,385,497 05/07/2002 Ogushi et al. 700 110 FOREIGN PATENT DOCUMENTS TRANSLATION YES/NO/ OR ABSTRACT DOCUMENT DATE COUNTRY CLASS **SUBCLASS** NUMBER OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.) **EXAMINER** DATE CONSIDERED

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.